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Date: March 11, 2004

TO: Examiner Kin Chan Chen (703) 872-9311
Art Unit: 1765

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Subject Matter: 10/ 047,266 Attorney Doc: 67,200-641

Message:

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Chih-Ming Ke

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Application No.: 10/047,266 (CONF 4511)

Group Art Unit:
1765

Filed: 1/14/2002

Examiner:
Kin Chan Chen

Title: Reducing photoresist shrinkage via plasma treatment

OFFICIAL

Attorney Docket No.: 67,200-641

Commissioner for Patents
Alexandria, VA 22313-1450Certificate of Facsimile Transmission

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office via facsimile no. (703) 872-9313 on the date shown below.

Date: Mar. 11, 2004

Kathy Dixon

SUPPLEMENTAL AMENDMENT

Dear Sir:

In response to an Advisory Action mailed March 5, 2004, and as a result of a telephone conference with Examiner Chen on March 11, 2004, please enter the following amendments and consider the following remarks.